

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Koos et al. Application No.: 10/690,084 Filed: October 20, 2003 Title: METHOD FOR FABRICATION OF SEMICONDUCTOR INTERCONNECT STRUCTURE WITH REDUCED CAPACITANCE, LEAKAGE CURRENT, AND IMPROVED BREAKDOWN VOLTAGE REQUEST FOR CONTINUED EXAMINATION (RCE) (37 CFR §1.114) Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 This is a Request for Continued Examination (RCE) of the above-identified application. Submission required under 37 C.F.R. §1.114: a. Previously submitted i. Consider the amendment/reply under 37 C.F.R. §1.116 previously filed on (Any unentered amendment referred to above will be entered.) ii. Consider the arguments in the Appeal Brief or Reply Brief previously filed on iii. Other b. Enclosed i. Amendment/Reply ii. Affidavit/Declaration iii. Improved the amendment with Form PTO-1449 Copies of IDS Citations iv. Other Other					
Filed: October 20, 2003 Title: METHOD FOR FABRICATION OF SEMICONDUCTOR INTERCONNECT Confirmation No.: 4873 STRUCTURE WITH REDUCED CAPACITANCE, LEAKAGE CURRENT, AND IMPROVED BREAKDOWN VOLTAGE CERTIFICATE OF MAILING Thereby certify that this conceptomelene is being deposited with the U.S. Postal Service with sufficient postage of fifty-class mail on June 1, 2007 in an envelope addressed to Commissioner for Patents. REQUEST FOR CONTINUED EXAMINATION (RCE) (37 CFR §1.114) Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 This is a Request for Continued Examination (RCE) of the above-identified application. 1. Submission required under 37 C.F.R. §1.114: a. Previously submitted i. Consider the amendment/reply under 37 C.F.R. §1.116 previously filed on	In re	applic	ation o	of: Koos et al.	The state of the s
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2. **Fees**: (The RCE fee is required at the time the RCE is filed.)

Fee Calculation (37 CFR §1.16)

Fee for Request for Continued Examination Under 37 C.F.R. §1.17(e)	\$790.00
TOTAL	790.00
SMALL ENTITY 50% FILING FEE REDUCTION (if applicable)	

- a. Applicant hereby petitions for a month extension of time.
 - b. Applicant believes that no (additional) extension of time is required; however, if it is determined that such an extension is required, Applicant hereby petitions that such an extension be granted and authorizes the Director to charge the required fees for an extension of time under 37 CFR §1.136 to Deposit Account No. 500388.
- C. Enclosed is our Check No. 13600 in the amount of \$790.00 to cover the RCE fee, extension of time and additional fees.
- d. The Director is authorized to charge any fees beyond the amount enclosed which may be required, or to credit any overpayment, to Deposit Account No. 500388 (Order No. NOVLP068)
- 3. Please continue to send correspondence to the following address:

Customer Number 022434

022434

Date: June 1, 2007

Anna Gavrilova

Registration No. 58,181

Registration No. 31,314